

ICC-273 PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

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For: SILICONE RESIN COMPOSITION) June 20, 2005

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REQUEST TO CORRECT INVENTORSHIP UNDER 37 C.F.R. § 1.48(a)(1)

Sir:

This Request to Correct Inventorship is filed to correct the omission of inventors of that which is defined by the subject patent application. The omitted inventors, Ikuo Takahasi and Hideji Tomita, have executed a declaration and a statement that their omission was through error and without deceptive intent (both enclosed).

Applicants request that the U.S. Patent Trademark
Office change the official records for this application, and
issue a corrected official Filing Receipt, noting the added
inventors.

The Commissioner is hereby expressly authorized to charge the fee required under 37 C.F.R. § 1.17(i) of \$130.00 to

Deposit Account No. 12-2135, and to charge any additional fees required by this Request or credit any overpayment thereof to that deposit account. A duplicate of this Request is attached for that purpose.

Applicants' undersigned attorney may be reached by telephone at (860) 571-5001 or by facsimile at (860) 571-5028.

All correspondence should continue to be directed to the address given below.

Respectfully submitted,

Steven C. Bauman

Attorney for Applicants Registration No. 33,832

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